



*IFW*

Docket No.: 9323.055.00-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
ATLAS, Boris

Confirmation No.: 6430

Application No.: 09/828,029

Art Unit: 3753

Filed: April 6, 2001

Examiner: L. V. Ciric

For: MULTI-CHANNEL TEMPERATURE  
CONTROL SYSTEM FOR SEMICONDUCTOR  
PROCESSING FACILITIES

Customer No.: 30827

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated August 28, 2006, please consider the following:

**The Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 14 of this paper.